

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: TSUTOMU YAMADA, ET AL.)
SERIAL NO.: 09/966,692) Group Art Unit: 2812
FILED: September 28, 2001)
FOR: METHOD OF ATTACHING LAYER)
MATERIAL AND FORMING LAYER)
IN PREDETERMINED PATTERN ON)
SUBSTRATE USING MASK)

AMENDMENT

Via EFS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is submitted in response to the Office Action dated July 28, 2006. If there are any additional charges with respect to this Amendment or otherwise, please charge them to Deposit Account No. 06-1130.

Please amend the Application as follows:

YKI-0078
09/966,692